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PATENT

Atty. Docket No.: 006915 USA M P02/FEP/P3I/PJT  
RW Ref. No.: APM/001-02-CP1-2

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
Kenneth Collins, et al.

Entitled: PLASMA IMMERSION ION  
IMPLANTATION APPARATUS USING A  
PLASMA SOURCE HAVING LOW  
DISSOCIATION AND LOW MINIMUM  
PLASMA VOLTAGE

Serial No.: 10/646,533

Filing Date: August 22, 2003

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Group Art Unit: 2813  
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Examiner: Jack S. Chen  
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**RESPONSE TO DOUBLE PATENTING REJECTION**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action (Double Patenting) dated July 9, 2008, applicants submit herewith a Terminal Disclaimer to overcome the double patenting rejection.

Although the claims have not been amended, a complete listing of claims is provided and begins on page 2.

**Remarks** begin on page 17 of this paper.